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High Contrast Metastructures XIV

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Contents

v *Conference Committee*

METASTRUCTURES: THERMAL, ENZ EFFECTS

13378 02 **Absorbing metamaterials with hyperbolic dispersion in the visible spectrum** [13378-24]

ACTIVE METASURFACE DEVICES

13378 03 **MEMS-based twisted bilayer flat optics for multidimensional optical modulation and hyperimaging** [13378-27]

META-OPTICS: APPLICATIONS

13378 04 **Metasurfaces for infrared multimodal microscopy** [13378-30]

13378 05 **Metalens metrology: challenges in objective assessment of image quality** [13378-32]

METASURFACES: APPLICATION FOR BIO

13378 06 **Planar objective design for multiphoton brain imaging** [13378-36]

METASURFACES: NEW FABRICATION METHODS

13378 07 **Deep glass etching technique and machine learning-based design for glass-based metasurfaces** [13378-39]

DESIGN/SIMULATION FOR METASTRUCTURE/METASURFACES

13378 08 **Single layer metasurface fulfilling metareflector and metalens for polarized photodetection** [13378-42]

13378 09 **Ray-tracing method for large-scale metalenses in multiwavelength imaging system** [13378-44]

13378 0A **Metasurface aberration correctors for improving broadband refractive lens system performance in the long-wave infrared** [13378-12]